

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

AXEL PREUSSE MARKUS NOPPER HOLGER SCHÜHRER

Serial No.: 10/747,722

Filed: December 29, 2003

For:

METHOD OF REDUCING WAFER CONTAMINATION BY REMOVING UNDER-METAL LAYERS AT THE

WAFER EDGE

Examiner: Edward J. Wojciechowicz

Group Art Unit: 2815

Att'y Docket: 2000.109700/DE0351

Customer No.: 23720

RESPONSE TO OFFICE ACTION DATED NOVEMBER 3, 2004

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

CERTIFICATE OF MAILING 37 C.F.R 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

November 19, 2004

Date

This paper is submitted in response to the Office Action dated November 3, 2004, for which the three-month date for response is February 3, 2005.

A fee in the amount of \$160.00 is believed to be due in connection with the present paper. The Director is authorized to deduct such fee, and any other fees required under 37 C.F.R. §§ 1.16 to 1.21, from the Advanced Micro Devices, Inc. Deposit Account No. 01-0365/DE0351. In the event the monies in that account are insufficient, the Director is authorized to withdraw funds from Williams, Morgan & Amerson, P.C. Deposit Account No. 50-0786/2000.109700.

Reconsideration of the application in view of the following amendments and remarks is respectfully requested.